

Title (en)

METHOD AND ARRANGEMENT FOR CONTROLLING A MULTI-PHASE SCREENING APPARATUS

Title (de)

VERFAHREN UND VORRICHTUNG ZUR STEUERUNG EINER MEHRPHASEN - SIEBEINRICHTUNG

Title (fr)

PROCEDE ET DISPOSITIF POUR COMMANDER UN DISPOSITIF DE CLASSAGE A ETAGES MULTIPLES

Publication

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Application

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Abstract (en)

[origin: WO9850624A1] The invention relates to a method for controlling a multi-step screening apparatus (1), the method comprising controlling other accept, reject and dilution flows in relation to the flow measured in the accept channel (7a) of the first screening step (3a). Thus a simpler control unit (9) can be used and accept of higher quality can be obtained than before. The invention further relates to an apparatus for controlling a multi-step screening apparatus (1), said apparatus comprising a control unit (9) arranged to measure the flows of all accept, reject and dilution water channels (7a-7c, 5a, 5b, 11a, 11b) and to adjust the flow of the other channels on the basis of the flow of the accept channel of the first step.

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